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RCE TRANSMITTAL LETTER(Large Entity) Applicant(s): Yoshi Ono					RECEIVED TRAL FAX CENTER		Docket No. SLA0669					
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Serial No	<u> </u>	Filing	Date		Examiner	G		roup Art Unit				
10/602,194		June 23, 2003			Khiem D. Nguyen	2823		2823				
Invention: Low Temperature Nitridation of Silicon												
TO THE COMMISSIONER FOR PATENTS:												
Transmitted herewith is an amendment in the above identified application.												
The fee has been calculated and is transmitted as shown below.												
CLAIMS AS AMENDED												
	1 .	REMAINING MENDMENT	HIGHEST# PREV. PAID F		NUMBER OF EXTRA CLAIMS PRESENT		RATE	ADDITIONAL FEE				
TOTAL CLAIMS	20) -	20 =		0	x :	\$18.00	\$0.00				
INDEP. CLAIMS		3 -	3 =		0	x :	\$88.00	\$0.00				
Multiple Dependent Claims (check if applicable) \$0.00												
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT \$0.00												
Please charge Deposit Account No. 19-1457 in the amount of \$790.00, which consists of the fee of \$790.00 specified in 37 CFR 1.17(e), plus any fee required by 37 CFR 1.111, as calculated above. A duplicate copy of this sheet is enclosed. A check in the amount of to cover the filing fee is enclosed. The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457. A duplicate copy of this sheet is enclosed. X Any additional fees required under 37 C.F.R. 1.16. X Any patent application processing fees under 37 C.F.R. 1.17. Dated: November 15, 2004												
David C. Ripma, Reg. No. 27,672 I hereby certify that this correspondence is being facsimal transmitted to the United States, Patent and Trademark												
Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on November 15, 2004. David C. Ripma, Reg. No. 2, 672												
Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted include:												
x This Request for Continued Examination Transmittal (Include Duplicate) 2 page(s)												
<u>x</u> RCE under 37 CFR § 1.114								'				
Attachments 0 page(s) pages								page(s) pages				
Petition	Petition for Extension of Time under 37 C.F.R. § 1.136 (Include Duplicate)											
Total pages, including this Transmittal: 18												

RCE TRANS		Docket No. SLA0669									
Applicant(s).	11/40003										
Filing			Date		Examiner	Gr	oup Art Unit				
Serial No		Filing Date June 23, 2003			Khiem D. Nguyen		2823				
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	CLAIMS AFTER A	REMAINING MENDMENT	HIGHEST # PREV. PAID F		NUMBER OF EXTRA CLAIMS PRESENT	RATE	FEE				
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Petition for Extension of Time under 37 C.F.R. § 1.136 (Include Duplicate)											
Total pages, including this Transmittal: 18											

Confirmation Number: 9996

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:

10/602,194

Applicant:

Yoshi Ono June 23, 2003

Filed: Group #:

2823

Examiner:

Khiem D. Nguyen

Docket No: SLA.0669

Customer No: 27518

For:

Low Temperature Nitridation of Silicon

MS RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT IN SUPPORT OF RCE UNDER 37 C.F.R. § 1.114 **Introductory Comments**

In response to the Office Action dated August 8, 2004, please amend the above-

identified Application as follows:

Amendment to the Specification None

Amendment to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendment to the Drawings None

Remarks/Arguments begin on page 7 of this paper.

An Appendix is not included.

Page 1

PRELIMINARY AMENDMENT IN SUPPORT OF RCE UNDER 37 C.F.R. § 1.114

for Serial No. 10/602,194